

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Heng Liu

Assignee: BridgeLux, Inc.

Title: Chemical Vapor Deposition Reactor

Application No.: 10/727,746 Filing Date: December 3, 2003

Examiner: Ram N. Kackar Group Art Unit: 1792

Docket No.: 70257.34 (M-15626-1D) Confirmation No.: 8880

Irvine, California
January 15, 2010

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

This communication is in response to the Non-Final Office Action dated September 15, 2009.

Claims begin on page 2.

Remarks begin on page 4.